PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

licant : Minoru Umemoto et al.) Group Art Unit

Serial No. : 10/585,707

Filed : July 10, 2006

For : PROCESS OF FORMING

ULTRAFINE CRYSTAL LAYER,
MACHINE COMPONENT HAVING
ULTRAFINE CRYSTAL LAYER
FORMED BY THE ULTRAFINE
CRYSTAL LAYER FORMING
PROCESS, PROCESS OF
PRODUCING THE MACHINE
COMPONENT, PROCESS OF
FORMING NANOCRYSTAL LAYER,
MACHINE COMPONENT HAVING
NANOCRYSTAL LAYER FORMED

FORMING NANOCRYSTAL LAYER, MACHINE COMPONENT HAVING NANOCRYSTAL LAYER FORMED BY THE NANOCRYSTAL LAYER FORMING PROCESS, AND PROCESS OF PRODUCING THE

MACHINE COMPONENT

Examiner : Christopher S. Kessler

AMENDMENT

Hon. Commissioner of Patents and Trademarks Alexandria, VA 22313-1450

Dear Sir:

This amendment is submitted for the above-identified patent application in response to the office action from the United States Patent and Trademark Office mailed December 30, 2009. Please make the following election and changes: